



IPW

Docket No.: SON-2626  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Koichi Takeuchi

Application No.: 10/506,792

Confirmation No.: 6537

Filed: September 7, 2004

Art Unit: 2812

For: A METHOD OF PRODUCING A  
SEMICONDUCTOR DEVICE AND A  
SEMICONDUCTOR DEVICE

Examiner: Not Yet Assigned

**FIRST PRELIMINARY AMENDMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Amendments to the Abstract** begin on page 6 of this paper.

**Amendments to the Explanation of References** begin on page 7 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.